

Substitute for form 1449A/PTO &amp; 1449B/PTO

**FIRST  
INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

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**of**

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**Complete if Known**

Application Number

Filing Date

March 11, 2005

First Named Inventor

Stephan Geiger et al.

**Examiner Name**

Attorney Docket Number

033033-025

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

## NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
NYZ	CHEN Y-F et al., "EFFICIENT HIGH-POWER DIODE-END-PUMPED TEMOO ND:YV04 LASER WITH A PLANNER CAVITY", Optics Letters, Optical Society of America, Washington, US, Vol 25, No. 14, July 2000, pages 1016-1018.
NYZ	HONEA E C et al., "183-W, M2 – 2.4 YB:YAG Q-SWITCHED LASER", Optics Letters, Optical Society of America, Washington, US, Vol. 24, No. 3, February 1, 1999, pages 154-156.
NYZ	CHEN Y F et al., "EFFICIENT HIGH-POWER DIODE-END-PUMPED TEMOO ND:YV04 LASER", IEEE Photonics Technology Letters, IEEE Inc., New York, US, Vol. 11, No. 10, October 1999, pages 1241-1243.
NYZ	SENNAROGLU A., "EFFICIENT CONTINUOUS-WAVE OPERATION OF A DIODE-PUMPED ND:YV04 LASER AT 1342 NM", Optical Communications, North-Holland Publishing Co., Amsterdam, NL, Vol. 164, No. 4-6, June 15, 1999, pages 191-197.
NYZ	HONEA E C et al., "115-W TM: YAG DIODE-PUMPED SOLID-STATE LASER", IEEE Journal of Quantum Electronics, IEEE Inc., New York, US, Vol. 33, No. 9, September 1, 1997, pages 1592-1600.

Examiner Signature	/Yuanda Zhang/	Date Considered	04/23/2007
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.